

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Shen et al.	Group Art Unit: 1763
Application No: 09/507,629	Examiner: Allan W. Olsen
Confirmation No: 7912	Attorney Docket No:
Filed: 2/18/2000	001945 USA P 03/ETCH/SILICON/JB1
Title: SELF-CLEANING PROCESS FOR ETCHING SILICON-CONTAINING MATERIAL	September 4, 2003 San Francisco, California

AMENDMENT IN RESPONSE TO FINAL OFFICE ACTION

Commissioner for Patents

Via Facsimile Transmission  
(703) 872-9311

Examiner Olsen:

This communication is in response to the Office Action mailed on June 4, 2003, and is being timely filed within three months thereof.

## Certificate of Transmission

I hereby certify that this correspondence is being facsimile transmitted to the U.S. Patent and Trademark Office via Fax No. (703) 872-9311.

By: Stephen Guzzi

Stephen Guzzi

Date: September 4, 2003